

<b>Notice of References Cited</b>	Application/Control No. 10/690,174		Applicant(s)/Patent Under Reexamination DRANEY ET AL.	
	Examiner William M. Brewster		Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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X	C	US-6,235,387 B1	05-2001	Bennett et al.	428/355AC
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	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Stanley Wolf Ph.D. and Richard N. Tauber Ph.D. in Silicon Processing for the VLSI Era, Volume 1: Process Technology, Lattice Press, 1986, pp. 238-9.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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